

Application/Control No.	Applicant(s)/Patent und Reexamination	der
10/676,775	FREDERICKSON, KIF	RK
Examiner	Art Unit	
Chong H. Kim	3682	

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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